



1/9

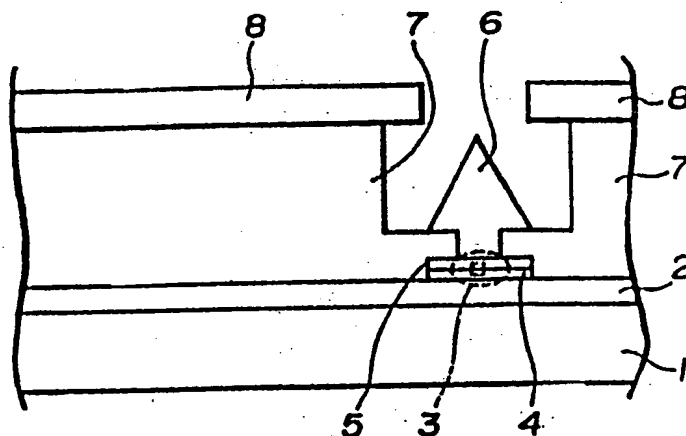


Fig. 1

Prior Art

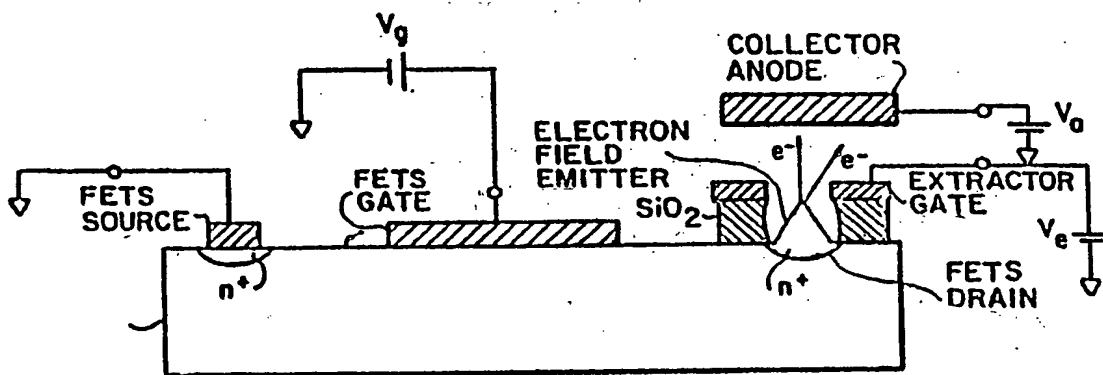


Fig. 2a

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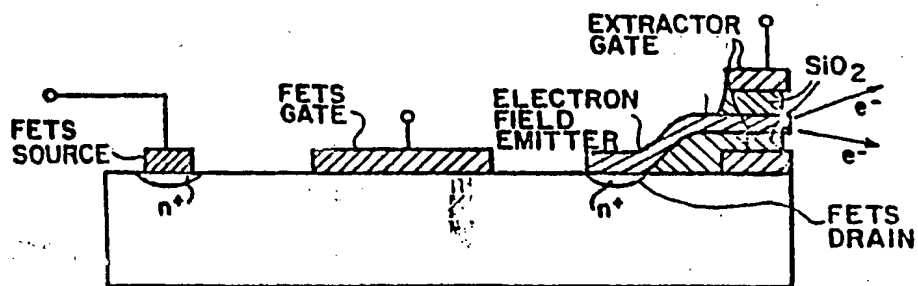


Fig. 2b

Prior Art

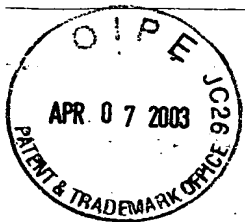
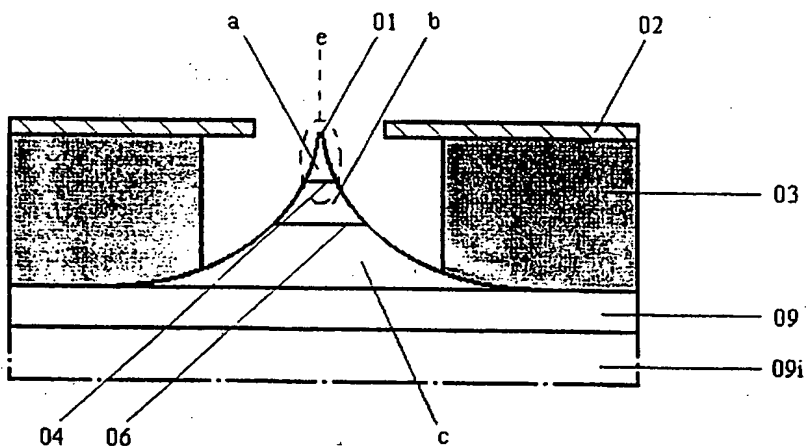
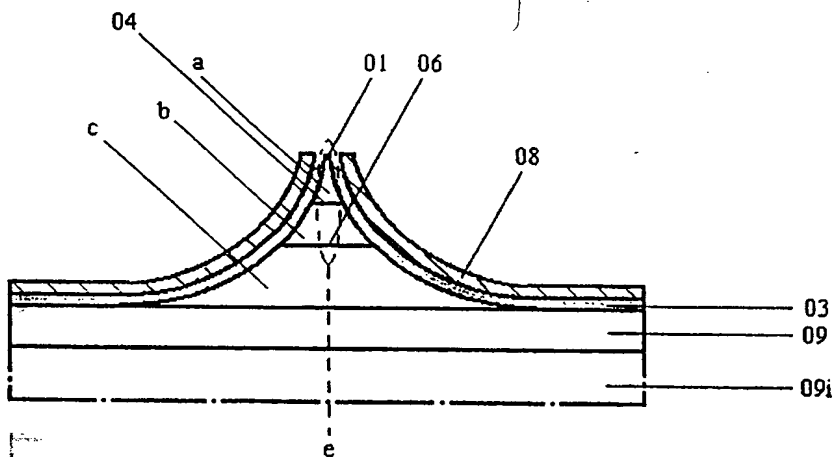


Fig. 3a



Prior Art

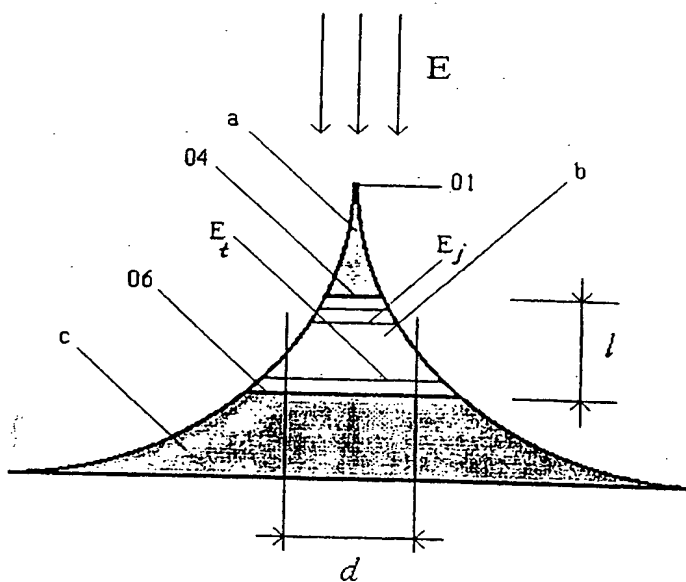
Fig. 3b



Prior Art

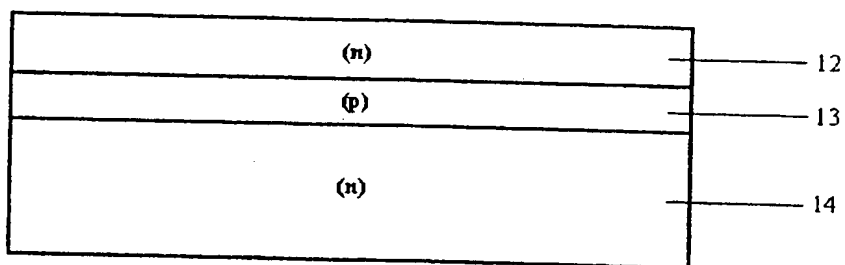


Fig. 3c



Prior Art

Fig. 3d

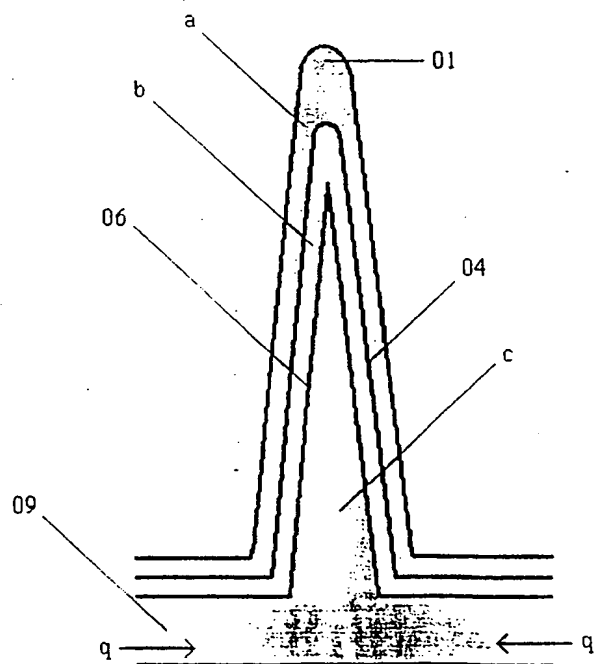
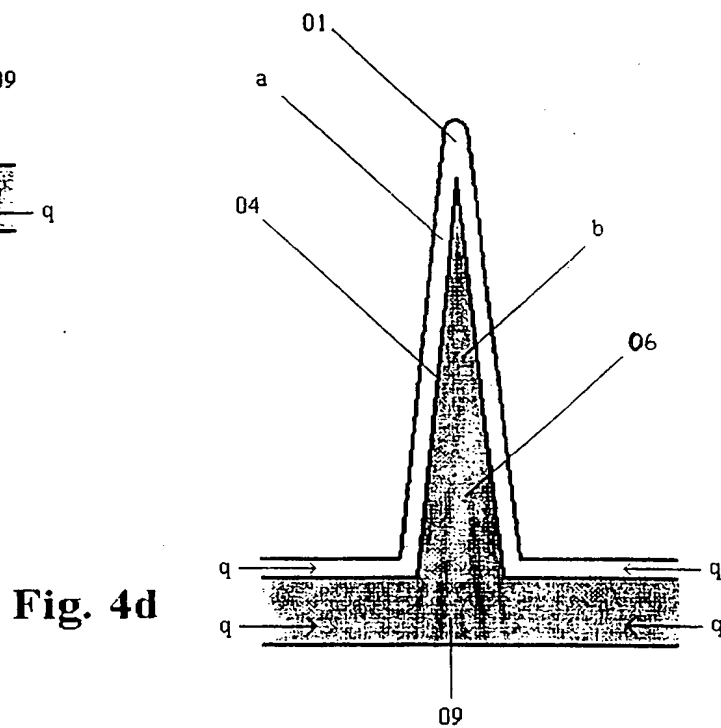
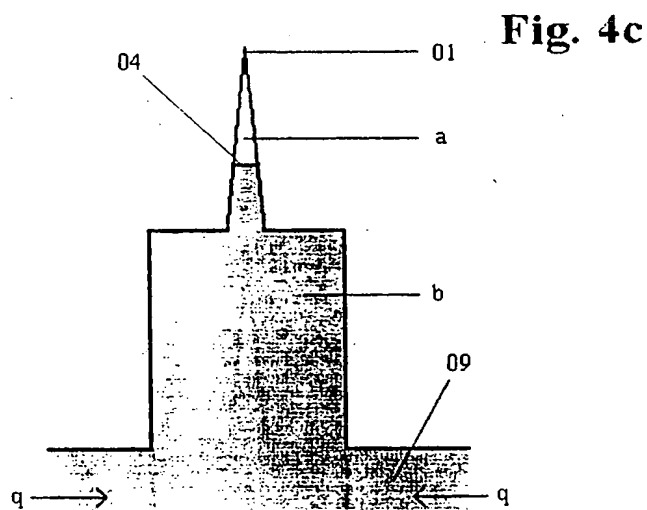


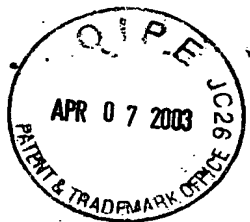
Prior Art



ELECTRONS SOURCES WITH WHISKER FIELD EMITTERS
AND METHOD OF MANUFACTURING (AS AMENDED)

Givargizov, et al.
Appl. No.: 09/674,415 Atty. Docket: GIVAR5.001APC





ELECTRONS SOURCES WITH WHISKER FIELD EMISSION
A METHOD OF MANUFACTURING (AS AMENDED)

Givargizov, et al.
Appl. No.: 09/674,415 Atty. Docket: GIVAR5.001APC

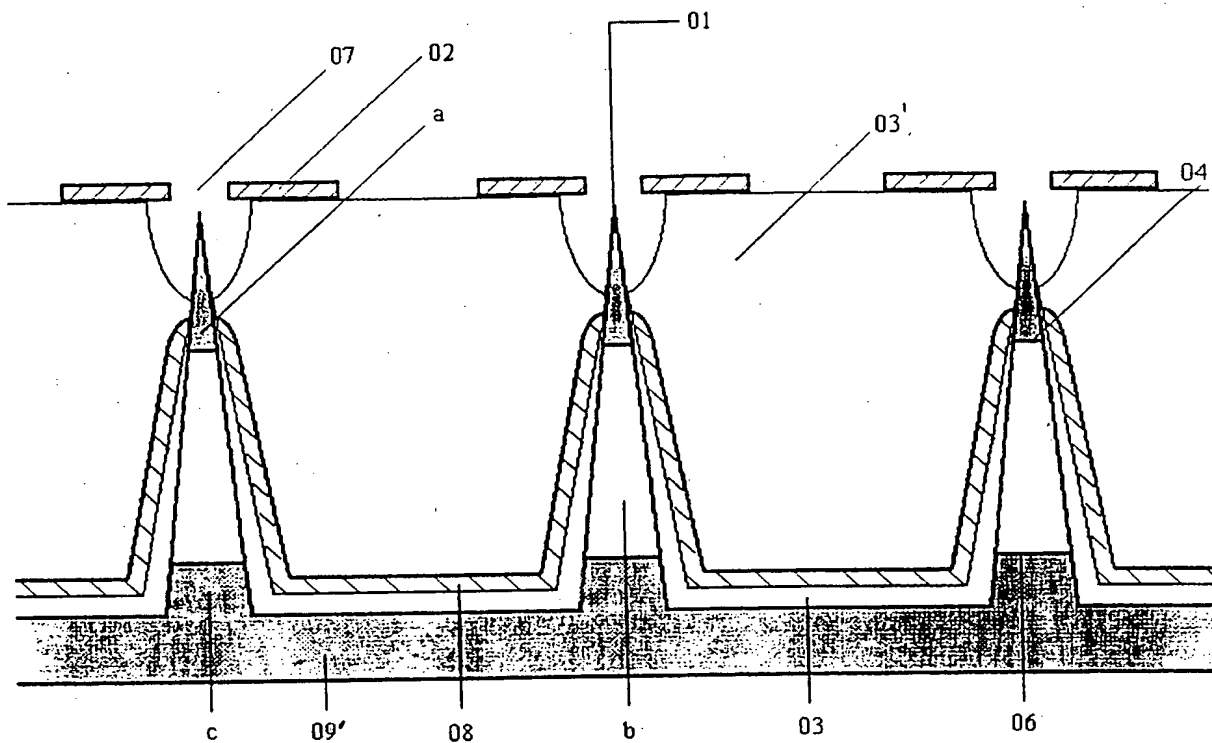


Fig. 6a

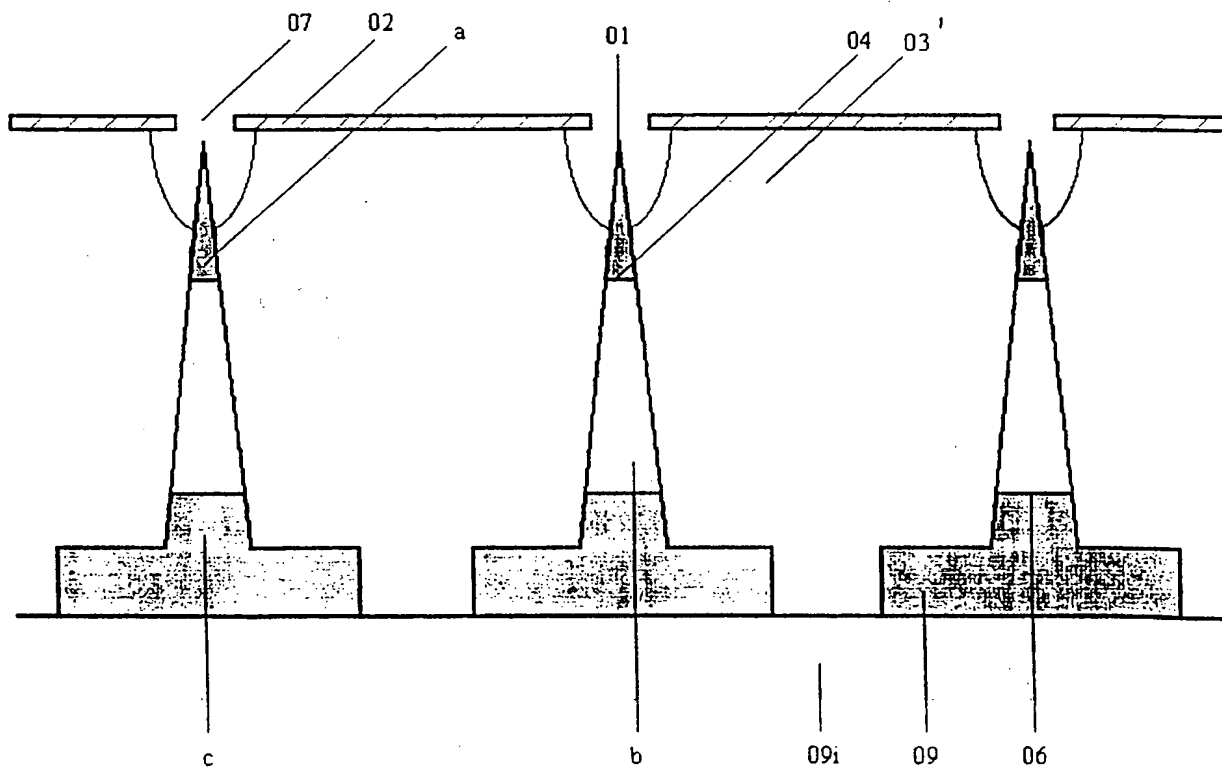


Fig. 6b